



Inventor:

Mathew S. Cooper

Title:

Physical Vapor Deposition Components and Methods of Formation

Assignee: Micron Technology, Inc.

Docket No. H0001190 (4016)

9/w.m.
5/20/03

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449


The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

12 May 2003

Attorney:


James E. Lake
Reg. No. 44,854

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